



PATENT  
Attorney Docket No. 01-099  
Express Mail Lab 1 No. EV417741166US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Rongxiang Hu, Philippe Schoenborn, )  
and Masaichi Eda )  
Serial No. 09/928,570 )  
Filed: August 13, 2001 )  
For: HIGH SELECTIVELY SiC ETCH )  
IN INTEGRATED CIRCUIT )  
FABRICATION )

Group Art Unit: 1765  
Confirmation No. 7873  
Examiner: L. Umez-Eronini  
AFTER FINAL

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DEC 23 2003

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AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action mailed October 22, 2003, please amend the application as set forth below in the Two Parts of this Amendment and Response.

IN THE CLAIMS:

Amend claim 1 as shown in Part 1 hereof.

REMARKS:

Part 2 comments on the above amendment, and the October 22, 2003 office action.